

Notice of References Cited

Application/Control No.

09/975,840

Applicant(s)/Patent Under
Reexamination
CHIANG, MIN-HSIUNG

Examiner

Belur V Keshavan

Art Unit

2825

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	C	US-6,078,492	06-2000	Huang et al.	361/301.4
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NON-PATENT DOCUMENTS

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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)

Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.